



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent application: )  
Hisato SHINOHARA et al. )  
Application Serial No. 08/169,127 ) Art Unit: 1762  
Filed: December 20, 1993 ) Examiner: Marianne L. Padgett  
For: LASER IRRADIATION METHOD ) Date: June 27, 2006  
(AS AMENDED)

**AMENDMENT**

Mail Stop **AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 27, 2005, please consider the following amendments and remarks in connection with this instant application.